Notice of Allowability	Application No.	Applicant(s)	
	10/699,805	YAMADA ET AL.	
	Examiner	Art Unit	
	Zia R. Hashmi	2881	p~
The MAILING DATE of this communication apperature All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this apport or other appropriate communication GHTS. This application is subject to	plication. If not include will be mailed in due	ed course. THIS
1. This communication is responsive to 9/10/2004.			
2. 🖾 The allowed claim(s) is/are <u>1-11</u> .			
3. \boxtimes The drawings filed on <u>04 November 2003</u> are accepted by	the Examiner.		
 4. Acknowledgment is made of a claim for foreign priority una a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 	been received. been received in Application No cuments have been received in this of this communication to file a reply	national stage applica	
5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give			OTICE OF
6. CORRECTED DRAWINGS (as "replacement sheets") mus (a) including changes required by the Notice of Draftspers 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1, each sheet. Replacement sheet(s) should be labeled as such in the state of the sheet.	on's Patent Drawing Review (PTO- s Amendment / Comment or in the C .84(c)) should be written on the drawing the header according to 37 CFR 1.121(Office action of ngs in the front (not the	
7. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT			vote the
Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	5. Notice of Informal F 6. Interview Summary Paper No./Mail Da 7. Examiner's Amendr 8. Examiner's Stateme 9. Other	(PTO-413), te ment/Comment	·

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DETAILED ACTION

Allowable Subject Matter

- An "Amendment" was received on September 10, 2004 in response to Office 1. Action of May 20, 2004. Claims 1-8 have been amended and new claims 9-11 have been added, as indicated.
- 2. Claims 1-11 are allowed.
- 3. The following is an examiner's statement of reasons for allowance:

With respect to amended independent claims 1 and 6, prior art fails to disclose a mass spectrometer which uses an atmospheric pressure chemical two-step ionization source composed of: a primary ionization part for generating primary ions by means of electric discharge of reagent gas like argon or helium; and a secondary ionization part for generating secondary ions of a sample by a reaction the primary ion and a sample to be introduced from a sample inlet. In a mass spectrometer of the present invention, a substance targeted for measurement of the order of parts per million in the sample is measured with as low a sampling flow rate as about 0.1 L/min. The primary ionization part is formed with an inlet for introducing reagent gas and an outlet for discharging gas for generating the primary ions. Between the primary ionization part and the secondary ionization part, there is arranged a counter electrode having a hole through which the primary ions are caused to pass through toward the secondary ionization part. The secondary ionization part is maintained at negative pressure as compared with the primary ionization part. The ions generated in the secondary ionization part are

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introduced into a mass spectrometric portion which has been evacuated in a high vacuum, through an aperture, and mass spectrometric analysis is performed by a mass spectrometer such as a quadrupole type, an ion trap type, or an ion trap-TOF type (time of flight type) mass spectrometer, or a magnetic field type mass spectrometer. The current invention is useful in evaluation of dynamic characteristics of a fuel cell, which requires high sensitivity and low flow rates. For example, in development of a fuel cell, in order to investigate mass balance of gas at inlet and outlet of the fuel cell for evaluating the power generation efficiency, it has become an important problem to confirm how the efficiency changes by changing parameters for temperature, flow rate and the like, online. A sample gas is collected from the fuel cell, traces of hydrogen in the sample gas is selectively ionized through the use of argon, or helium, or nitrogen as dilution gas, and through the use of the atmospheric pressure chemical two-step ionization source, traces of hydrogen are measured online with a high sensitivity in real time.

Claims 2-5 and 7-11 are allowed by virtue of their dependencies on the independent claims 1 and 6.

Conclusion

4. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments of Statement of Reasons for Allowance".

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5. Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you

have questions on access to the Private PAIR system, contact Electronic Business

Center (EBC) at 866-217-9197 (toll-free).

6. Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Zia Hashmi whose telephone number is (571) 272-2473.

The examiner can normally be reached between 8.30 AM- 5 PM. If attempts to reach

the examiner by telephone are unsuccessful, the examiner's supervisor, John R. Lee

can be reached on (571) 272-2477.

Zia Hashmi

September 29, 2004

SUPPLISORY PATENT EXAMINER
ECHNOLOGY CENTER 2800